

Citations for Ion : **Hg**

Pub. Year	Authors, Title, Journal Citation and Comments	Citation Numb
1965	Brown, F. Ball, G. C. Channing, D. A. Howe, L. M. Pringle, J. P. S. 'Ranges of Heavy Ions' <i>Nucl. Inst. Methods, 38, 249-53 (1965)</i> <i>Comment : R, dR. (20-150 keV) Na, K, Kr, Xe, Rb, Ce, Hg, Au -> Au, W, Si, Al, UO2 (Crystals)</i>	1965-Brow
1966	Nielsen, O 'Specialeopgave' <i>Niels Bohr Institute, University of Copenhagen, Pp. 1-64 (1966)</i> <i>Comment : S, dS. 50 keV C, Na, Cl, K, Mn, Y, Zn, Ag, Hf, Lu, Hg, Bi -> H2, D2, He, N2, Ne, Ar</i>	1966-Niel
1975	Hvelplund, P. 'Energy Loss and Stragglng of 100-500 keV 90Th, 82Pb, 80Hg, and 64Gd in H2' <i>Phys. Rev. A, 11, 1921-27 (1975)</i> <i>Comment : S, dS. 100-500 keV Gd, Hg, Pb, Th -> H2</i>	1975-Hvel
1977	Guttner, K. Hofmann, S. Marx, D. Munzenberg, G. Nickel, F. 'Range and Range Stragglng of Heavy Ions in Solids' <i>Nucl. Inst. Methods, 146, 413-417 (1977)</i> <i>Comment : R, dR. 0.2-0.5 MeV/amu Ba, Pr, Hg, Pd, Ba, Pr, Ce -> Ta, Ni, Au. Ranges Of Radioactive Recoils</i>	1977-Gutt
1979	Santry, D. C. Werner, R. D. Westcott, O. M. 'The Range of 120 keV Ions in Solids' <i>IEEE Trans. Nucl. Sci., Ns-26, 1331-1334 (1979)</i> <i>Comment : R, dR. 120 keV Mg, Al, P, S, Cl, K, Ar, Cr, Mn, Cu, Zn, Ga, As, Br, Kr, Rb, Ag, In, Sn, Sb, Te, I, Xe, Cs, Ba, Pr, Au, Hg, Tl, Pb, Bi -> Be, C, Al, Si</i>	1979-Sant
1980	Besenbacher, F. Bottiger, J. Laursen, T. Loftager, P. Moller, W. 'Z1-Oscillations in Low-Energy Heavy-Ion Ranges' <i>Nucl. Inst. Methods, 170, 183-188 (1980)</i> <i>Comment : R, dR. Atomic Numbers 18-92 (epsilon=.015) -> Si</i>	1980-Bese2
1982	Geissel, H. Laichter, Yl Schneider, W. F. W. Armbruster, P. 'Energy Loss and Energy Loss Stragglng of Fast Heavy Ions in Matter' <i>Nucl. Inst. Methods, 194, 21-29 (1982)</i> <i>Comment : S. Heavy Ions (18 - 92) at 0.5-10 MeV/amu -> 17 Solids and 5 Gases</i>	1982-Geis
1984	Wilson, R. G. Jamba, D. M. Hapkins, C. G. Norberg, J. C. 'Unannealed and Annealed Depth Distribution of Mercury Implanted into Silicon' <i>J. Appl. Phys., 55 (2), 327-330 (1984)</i> <i>Comment : R, dR. Hg (300-900 keV) -> Si</i>	1984-Wils
1986	Wang, K. M. Liu, X. J. Wang, Y. H. 'Range Distributions of 50-400 keV Hg in Amorphous Silicon wand Si-Ar Binary Targets' <i>Nucl. Inst. Methods, B17, 203-206 (1986)</i> <i>Comment : R, dR. Hg (50-400 keV) -> Si, SiAr</i>	1986-Wang

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1988	Wang, K. M. Liu, X. J. Wang, Y. H. Shi, B. R. Liu, J. T. 'Mean Projected Range and Range Straggling of 50-400 keV Hg in Glass' <i>J. Appl. Phys.</i> , 64 (7), 3341-3344 (1988) <i>Comment : R, dR. Hg (50-400 keV) -> Glass (Na, Mg, Al, Si, K, Ca, O)</i>	1988-Wang
1988	Wilson, R. G. '(111) Random and (110) Channeling Implantation Profiles and Range Parameters in HgCdTe' <i>J. Appl. Phys.</i> , 63, 5302-5311 (1988) <i>Comment : R, dR. 45 Ions (H to Ta) at 100-700 keV -> HgCdTe</i>	1988-Wils
1988	Wilson, R. G. 'Ion Implantation and SIMS Profiling of Impurities in II-VI Materials HgCdTe and CdTe' <i>J. Crystal Growth</i> , 86, 735-743 (1988) <i>Comment : R, dR. 52 Ions (H-Hg) at 100-700 keV -> CdTe, HgCdTe</i>	1988-Wils2